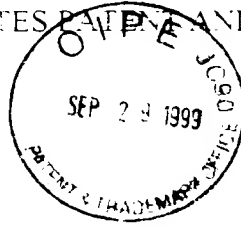


PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re the Application of

Yunlong LI et al.

Application No.: 09/123,352

Filed: July 28, 1998

For: PLASMA GENERATION APPARATUS

Group Art Unit: 1763

Examiner: R. Zervigon

Docket No.: 100869

AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action mailed March 29, 1999, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend claims 1 and 16 as follows:

Claim 1, line 20, before "center" insert --a--.

16. (Amended) A plasma generation apparatus comprising:

a vacuum vessel having a plasma generation region established in the interior

thereof;

gas induction means for inducting discharge gas into said interior of said

vacuum vessel;

exhaust means for exhausting the atmosphere in the interior of said vacuum

vessel;

Handwritten notes: "Sub E16" and "E16" with a checkmark.